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SERIAL NUMBER 10/565,767	FILING or 371(c) DATE 01/24/2006 RULE	CLASS 526	GROUP ART UNIT 1793	ATTORNEY DOCKET NO. OGOSH43USA		
APPLICANTS Yuichiro Shindo, Ibaraki, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/05389 04/15/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-279695 07/25/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/18/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/MARK L SHEVIN/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance <u>/MLS/</u> Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 0	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
ADDRESS HOWSON AND HOWSON SUITE 210 501 OFFICE CENTER DRIVE FT WASHINGTON, PA 19034 UNITED STATES						
TITLE Highly pure hafnium material, target thin film comprising the same and method for producing highly pure hafnium						
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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